



SN: 10/761,613
Art unit : 2826
Reply to Office Action dated Nov. 03, 2004
Docket: CS03-050

IFW
page 1 of 4

To: Commissioner of Patents,
P.O. Box 1450
Alexandria, VA 22313-1450,

From: William J. Stoffel
Reg no . 39,390
Customer no. 30,402

1735 Market St - Ste A455
Philadelphia, PA 19103

Subject:

SN: 10/761,613
Art unit : 2826
Reply to Office Action dated Nov. 03, 2004
Docket: CS03-050
Inventor: Chui
Title : **STRUCTURE AND METHOD TO FORM SOURCE
AND DRAIN REGIONS OVER DOPED DEPLETION
REGIONS**

Examiner: Erden

RESPONSE TO OFFICE ACTION

Dear Sir:

This is in response to the Office action dated Nov 3, 2004, please consider
the following remarks:

REMARKS/ARGUMENTS begin on page 2 of this paper.

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being :

☐ FAXED to the central facsimile number of patent and trademark office at the following number 703) 872-9306
or

☒ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner
of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on Nov 11, 2004.

Signature/Date William J. Stoffel 11/10/04
William J. Stoffel Reg. No. 39,390 Customer number 30402